Low Cost Microcontroller Based Decay Measurement System for Display Phosphors

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Abstract An attempt is made to design and develop a low cost, simple but efficient instrument to measure the decay time of luminescence in phosphors used in displays. The approach employed here is generally an embedded system designed around an intelligent microcontroller Atmega-16 of Atmale. The system is using a time domain technique of measurement and is further enhanced by developing necessary software for online-offline analysis.

Keywords: low cost, luminacencence, embedded sysytem, time doaim analysis, standalone system

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1. Introduction

Large flat-panel information displays or home cinemas, including rapidly developed 3D (three dimensional) devices, are characteristic examples of utilizing and commercializing the rapidly developing advances in the technology of plasma display panels (PDPs) in our daily life [1,2]. Plasma better satisfies the needs of high-quality 3D displays than LCD/LED. The main reason is that it provides much faster refresh rate, which is an important feature in suppressing lagging or blurring effects. Moreover, the best true resolution of an LCD/LED TV screen can achieve a (maximum) display of 700 or 800 lines at 240 Hz, whereas a plasma screen can achieve a display of 1080 lines at 600 Hz. The excitation source of PDPs is actually the result of the discharge of a noble gas in vacuum, which occurs in the ultra- violet region of the light spectrum. For instance, the discharge of Xe emits photons with wavelengths at 147 nm and 172 nm. Thus, phosphors have emerged as materials of particular interest for light conversion. In other words, the quality of PDPs strongly depends on the quality of phosphors. Suitable phosphors for these applications should feature high efficiency, stability, strong vacuum ultraviolet (VUV) absorption, good colorimetric purity, and proper decay time. With regard to the latter feature, the decay time for 3D PDPs must be extremely short to avoid cross- talk; thus, the decay time of the phosphor should be short enough (within about 2ms) [2,3,4].

PDP phosphors generate light by transitions in activator ions (i.e. Ce^{3+} , Tb^{3+} or Mn^{2+}). Therefore, phosphor decay time mainly depends on the transition rate of activator. With a low transition rate, phosphors continue to emit light until the most excited activators lose their energy by slow transition. Thus, phosphor decay times are long with low transition rates. Conversely, a fast- decaying phosphor has a high transition rate.

In 3D PDP, satisfactory CIE chromaticity coordinates and decay time of phosphors were attained by adjusting the phosphor mixture. Long lasting phosphors have the decay time in minutes, hours, days etc.

There are two complementary techniques of Decay time measurement: the time domain and the frequency domain. In the time domain, a short pulse of light excites the sample, and the subsequent emission is recorded as a function of time. In the frequency domain, the sample is excited by a modulated source of light. The luminescence emitted by the sample has a similar waveform, but is modulated and phase-shifted from the excitation curve. Both modulation (*M*) and phase-shift (φ) are determined by the decay time of the sample emission; that decay time can be calculated from the observed modulation and phase-shift [5]. In order to measure the decay time of luminescence in prepared phosphors, the instrument was design using time domain technique.

$$E1(d1 + X)2 = E2(d2 + X)2 -$$
(1)

X gives the distance between excitation source and the material holder.

Radiance and Luminance:

Radiance is a measure of the flux density per unit solid viewing angle, expressed in W/cm2/sr. Radiance is independent of distance for an extended area source, because the sampled area increases with distance, cancelling inverse square losses. The radiance, L, of a diffuse (Lambertian) surface is related to the radiant acceptance (flux density), M, of a surface by the relationship:

$$L = M / p \tag{2}$$

$$E = pL \sin^2 (q/2)$$
 (3)

Irradiance from an Extended Source:

The irradiance, E, at any distance from a uniform extended area source, is related to the radiance, L, of the source by the following relationship, which depends only on the subtended central viewing angle, of the radiance detector:

1.1. System Description

The complete system is constructed using the available components and tools easily available. The block diagram of a system shown in Figure 1.



Figure 1. Block diagram of the system

It consists of a light sensing element as LDR. LDR varies the resistance of the material when it exposed to the light, same property of LDR is used for intensity calculation. As the light falls on the LDR surface the resistance of the device is reduce in proportionate with the light fall and produce the appropriate voltage. The voltage getting from the LDR is not at that much high level to drive the direct readout. The voltage from the LDR is amplified with the signal conditioning block, which consist of IC TL 072, single power supply IC. This amplified voltage is feed to the digital world using the microcontroller Atmega-16. The analog voltage is converted using the inbuilt 10-bit resolution ADC acceptable in microcontroller [6]. The microcontroller is programmed in such way that the voltage received at the ADC input is converted into the LUX using inter conversion formula. The voltage converted into the standard string formation is needed by LCD. The analog voltage as well as the converted voltage in lux is shown on LCD screen.

1.2. Algorithm of the System

1. First step is to initialize keys, Interrupt vectors panel and LCD Define port B of microcontroller ATmega 16/32 as output port and Port A as Input for ADC. 2. Get data through ADC from two different channels of Temperature and Light Intensity continuously after a fixed interval.

3. Value obtained from different channels converted to appropriate form of display.

4. Display the appropriate values of input voltage from LDR and Light Intensity on LCD.

5. Start hardware device to glow a light if sensed light intensity is higher than the set value implying darkness.

6. New value of light intensity can be set using light converted into voltage.

7. New value of transfer rate of data to RS232 is set using keypad as follows.

2. Design Frame Work

2.1. System Design

The design process is divided into two: Hardware and Software designs.

2.1.1. Hardware Description

Figure 2 gives the schematic diagram of the system. Whole circuit diagram is divided into following sections: -



Figure 2. Complete schematic of the system

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(a) *Power supply section:* The regulated power supplies section made with full wave rectifier (with IN 4007 diodes) using voltage regulator IC 7805 and IC 7812 which provide a constant voltage of 5V to the circuit as well as constant 12V to relays.

(b) Analog to digital conversion section: Since we have to sense analog parameter i.e. light hence we have to use any analog to digital converter. We have opted for ADC 0809 as it has 8 channels and is microprocessor compatible ADC which is easily available [7]. It will convert the analog signal of the transducer to digital value with respect to the reference voltage, which in our case is 5V. This reference voltage is obtained using microcontroller Vcc supply voltage, which shifts the reference of ADC as AREF or Vcc voltage reference with output voltage range of 0.1 to 4.88V [8].

For the conversion ADC requires a reference frequency which is supplied from inbuilt oscillator available in controller also can be calculated from the crystal oscillator, which work as system clock, in the form of a stable oscillator. The conversion frequency is kept around 1000 kHz. Sensor used for light intensity is LDR. We have considered the reference voltage of ADC as standard for light intensity measurement. In that process 5V is considered as full light and 0V is considered as darkness. The light intensity is hence displayed in LCD as the reference voltage itself. The voltage scan by ADC is converted into per bit value using the percales, by multiplying 0.00482812 convert the scan voltage into the voltage proportional to light incident. This value is set with bit resolution and reference voltage applied. We used 10 bit ADC with voltage is 5V and bit is $1024(2^{10})$

(c) Controller section: The analog value is converted to digital value by inbuilt ADC and is picked up by microcontroller Atmega32 that is a 40pin device. The microcontroller is a low-power, high-performance CMOS 16-bit microcomputer with 8K bytes of Flash programmable and erasable read only memory (EPROM) [9].



display shows the voltage receives from the LDR and counted LUX. For decay measurement the measurement logic maximum light gives maximum LUX value and minimum light gives minimum LUX.

(f) Light control section: This section consists of another 5V relay to control hardware such an LED to glow at a particular voltage indicating darkness as set by the user.

(g) Hardware controlling: Simple push buttons are used to start the system as well as to give the time of data transfer to the PC

(*h*) *Data transfer:* Displayed data of light intensity are transferred to RS 232 which is interfaced with microcontroller through MAX232 [12,13].

Figure 3 shows the Embedded Control Hardware Circuit with serial communicator RS232

2.1.2. Software Description

Software development for the project consists of two main modules one being the online monitoring and controlling and other offline analysis based on data stored in computer. Software is developed in both C and Assembly language. The flowchart for the program is shown in Figure 4. The value of lux is calculated using the following equation.

$$Vout = adc_read()*0.0048828125$$
 (4)

Lux = 500 /
$$((10.7639 * [(5 - Vout)]) / Vout)$$
 (5)

$$RLDR = \left[10000*(5-Vout)\right]/Vout$$
(6)



Figure 4. Controlled program flowchart

Figure 3. Embedded Control Hardware Circuit with serial communicator RS232

(d) Display section: Since we need to display the data we get from microcontroller a liquid crystal display 44780 LCD is used which is a 2x16 line display [10,11]. The

2.2. Calibration

The photodiode, a 10 x 10 mm^2 planar silicon cell coated with synthetic quartz is used. The photodiode is mounted behind a precisely measured 7.98-mm diameter circular aperture, yielding an active area of 0.5 cm². The responsively is usually given every 5 nanometers. The calibration labs use this transfer standard to calibrate their inter-comparison working standards using a monochromatic light source. These working standards are typically identical to the equipment that will be calibrated [15].

Detectors are most often calibrated at the peak voltage at the minimum calibration check of the detector combination using identical biasing registers for the intended application. The key to this calibration transfer is a reliable kinematic mount that allows exchangeability of PIN detectors in place of LDR in the optical path, and a stable, power regulated light source. Here the calibration process is carry out with the reference of change in resistance against fixed biased resistor which is 3.3k [14,15].

$$RL = 500 / LUX$$

$$V_0 = 5*(RL / (RL + 3.3k))$$
(6)

$$LUX = (2500 / V_0 - 500) / 3.3k$$

3. Performance, Evaluation and Testing

The system for measuring decay was verified by varying the intensity of LED using potentiometer and measuring the intensity in LUX with respect to time. The decay measurement using three types of LEDs (5W, 1W and low grade LED) were also done. Table 1 shows the respective intensity with reference to time after the LED is turned off. This data is also represented on graph as shown in Figure 5.

Table 1. Intensity of LED's (5W, 1W and low grade) with respect to time.

Time in (ms)	5W LED	1 watt LED	Low grade LED	Accuracy Photometer 5w LED	Accuracy %(percent)
6ms	5200	2000	200	5100.54	1.03
12ms	2800	1930	193	2775.77	0.8653
18 ms	1500	1560	156	1485.60	0.96
24 ms	830	1370	137	830.22	0.0265
30 ms	750	1230	123	750.56	0.07466
36 ms	700	1130	113	700.23	0.032
42 ms	642	1023	102.3	642.33	0.0514
48 ms	570	950	95	570.45	0.07894
54 ms	523	725	72.5	523.22	0.0420
60 ms	435	460	46	435.86	0.1977
66 ms	370	320	32	370.22	0.0594
72 ms	290	241	24.1	290.11	0.03793
78 ms	168	115	11.5	168.33	0.1964
84 ms	130	75	7.5	130.44	0.3384
90 ms	85	42	4.2	85.33	0.3882
96 ms	57	35	3.5	57.05	0.08771
103 ms	39	15	1.5	39.65	1.666
109 ms	21	9	0.9	21.45	2.14
115 ms	16	5	0.5	16.66	4.125
121 ms	9	5	0.5	9.33	3.666
127 ms	5	5	0.5	5.66	13.3



Figure 5. Decay measurement w.r.t. time

4. Conclusion

The system to measure the decay time is successfully designed and is giving satisfactory results with the average accuracy of 1.3845 LUX measured with the standard photometer. This low cost, simple system can be used to measure the decay of luminescence in phosphors used in display. The results observed from ta Table 1 shows that as time increases the accuracy of the system is decreases as bit resolution voltage increases from 625 mV/Bit to 1.38V/Bit.

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